GAS SUPPLY SYSTEM AND METHOD

ABSTRACT

A gas supply system is provided. The gas supply system includes a supply line configured to connect a gas container to a process object, a purge line connected to a first point of the supply line and connected to a purge gas supply portion configured to supply a purge gas, a first exhaust line connected to a second point of the supply line and connecting the supply line to an exhaust portion configured to apply negative pressure, and a second exhaust line connected to a third point of the purge line and connecting the purge line to a fourth point of the first exhaust line. The first point of the supply line is closer to the gas container than the second point is.

FIG. 1